



Docket No.: 210314US2

2814
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RE: Application Serial No.: 09/895,319

Applicants: Toshiaki SHINOHARA

Filing Date: July 2, 2001

For: SEMICONDUCTOR DEVICE AND METHOD OF
MANUFACTURING SAME

Group Art Unit: 2814

Examiner: NGUYEN, D. P.

SIR:

Attached hereto for filing are the following papers:

REQUEST FOR RECONSIDERATION

Our check in the amount of -0- is attached covering any required fees. In the event any variance exists between the amount enclosed and the Patent Office charges for filing the above-noted documents, including any fees required under 37 C.F.R. 1.136 for any necessary Extension of Time to make the filing of the attached documents timely, please charge or credit the difference to our Deposit Account No. 15-0030. Further, if these papers are not considered timely filed, then a petition is hereby made under 37 C.F.R. 1.136 for the necessary extension of time. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

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